

Subst. Form PTO-1449				Docket Number (Optional) SAM-0279		Application Number	
INFORMATION DISCLOSURE CITATION IN AN APPLICATION <i>(Use several sheets if necessary)</i>				Applicant Je-suk Lee, et al.			
				Filing Date Herewith		Group Art Unit Not yet assigned	
U. S. Patent Documents							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES NO
BO	AL	9186938	97-07-15	Japan	H04N5	335	X
BO	AM	2000101937	2000-04-07	Japan	H04N5	335	X
BO	AN	10304238	98-11-13	Japan	H04N5	232	X
BO	AO	10341377	98-12-22	Japan	H04N5	335	X
	AP						
	AQ						
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
	AR						
	AS						
	AT						
EXAMINER <i>Brian Jelenick</i>				DATE CONSIDERED <i>1/6/2005</i>			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy with next communication to applicant.							

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 10/000267
 11/02/01